

INVENTOR INFORMATION

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CORRESPONDENCE INFORMATION

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APPLICATION INFORMATION

Title Line One:: METHOD OF FORMING SILICON-BASED THIN FILM,

Title Line Two:: SILICON-BASED THIN FILM AND PHOTOVOLTAIC

Title Line Three:: ELEMENT

Total Drawing Sheets:: 5

Formal Drawings?: Yes

Application Type:: Utility

Docket Number:: 35.C15381

Secrecy Order in Parent Appl.?: No

706250 6459860

REPRESENTATIVE INFORMATION

Representative Customer Number:: 05514

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2000-162805

Filing Date:: 05-31-2000

Country:: Japan

Priority Claimed:: Yes

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